



**ELECTRONIC COPY**

LG665416021  
Report verification at igi.org



November 18, 2024  
IGI Report Number **LG665416021**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **14.05 - 14.16 X 8.21 MM**  
**GRADING RESULTS**  
Carat Weight **10.02 CARATS**  
Color Grade **E**  
Clarity Grade **VS 2**  
Cut Grade **EXCELLENT**

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**GRADING RESULTS**

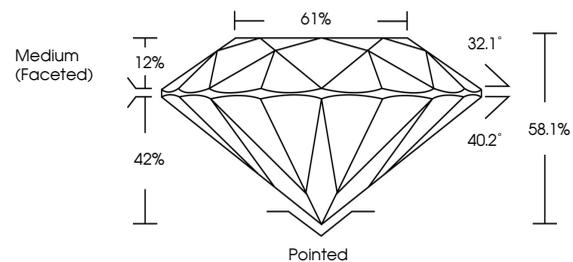
Carat Weight **10.02 CARATS**  
Color Grade **E**  
Clarity Grade **VS 2**  
Cut Grade **EXCELLENT**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG665416021**

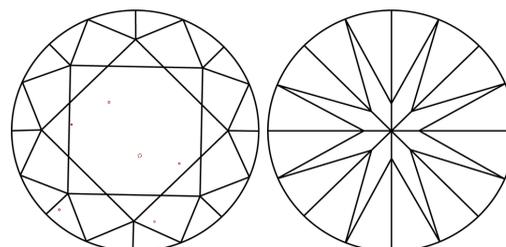
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

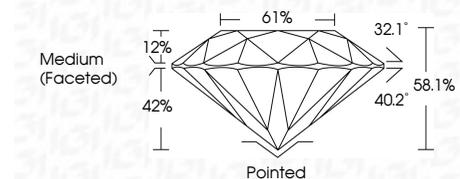
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	WS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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**IGI**



November 18, 2024  
IGI Report No LG665416021  
**ROUND BRILLIANT**  
**10.02 CARATS**  
E  
Color Grade  
VS 2  
EXCELLENT  
14.05 - 14.16 X 8.21 MM  
Depth  
61%  
61%  
Medium (Faceted)  
Culet  
Pointed  
Polish  
EXCELLENT  
Symmetry  
EXCELLENT  
Fluorescence  
NONE  
Inscription(s)  
IGI LG665416021  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa